

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination BOUKHERROUB ET AL.	
		Examiner Mahmoud Dahimene	Art Unit 1765	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,284,671	09-2001	Schmuki et al.	438/745
*	C	US-2002/0158256	10-2002	Yamada et al.	257/79
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	E	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Sieval et al. "Highly stable Si-C linked functionalized monolayers on the silicon (100) surface", Langmuir, 1998, Vol. 14, No. 7, pages 1759-1768.
	V	Effenberger et al. "Photoactivated preparation and patterning of self-assembled monolayers with 1-alkenes and aldehydes on silicon hydride surfaces" Angew. Chem. Int. Ed. 1998, 37, No. 18, pages 2462-2464.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.